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Applicant: John T. Moore et al.
Serial No.: 09/496,794
Filed: February 2, 2000
For: Trench Isolation for
Semiconductor Devices

§ Group Art Unit: 2811
§
§
§ Examiner: Douglas Owens
§
§
§ Atty. Dkt. No.: MCT.0005D1US
§ 97-0608

TECH CENTER 2800

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO PAPER NO. 20

Sir:

In response to the office action mailed May 5, 2004, please amend the above-referenced patent application as follows.

Date of Deposit: July 13, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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